

Notice of References Cited	Application/Control No. 10/779,864	Applicant(s)/Patent Under Reexamination KRIJNEN, EDWIN EDUARD NIC	
	Examiner Samuel A. Turner	Art Unit 2877	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,285,457	09-2001	Ukaji, Takao	356/500
*	C	US-6,875,992	04-2005	Castenmiller et al.	250/548
*	D	US-6,876,453	04-2005	Van Doren et al.	356/498
*	E	US-7,158,236	01-2007	Schluchter, W. Clay	356/500
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peggs et al, Design for a Compact High-Accuracy CMM, CIRP Annals, vol. 48/1, 1/1999, pp. 417-421.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.